

Applicant : Eiji Nishibe et al.  
Serial No. : 09/944,452  
Filed : August 31, 2001  
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Attorney's Docket No.: 10417-  
093001 / F51/137275M/TOM

Amendments to the Specification:

Please replace the title beginning at page 1, line 1 as with the following amended title:

Semiconductor Device ~~and Manufacturing Method Thereof~~ Using One Element  
Separation Film